

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV.7-80) PATENT AND TRADEMARK OFFICE										Atty. Docket No. GB 010071		Serial No.			
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)										Applicant Pieter J. Van der ZAAG et al.		Filing Date CONCURRENTLY		Group	
U.S. PATENT DOCUMENTS															
Ex. Int.		Document Number								Date	Name	Class	Sub-class	Filing Date If Approp.	
	AA	5	1	3	0	8	2	9	7/14/92	Shannon	359	59			
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FOREIGN PATENT DOCUMENTS															
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OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)															
	AL	"Excimer-Laser-Produced Amorphous Silicon Vertical thin Film Transistors" by A. Saitoh et al, Jpn. J. Appl. Phys. Vol. 36 (1997) pp. 668-9													
	AM	"IBM Technical Disclosure Bulletin, Vol. 29 No. 5, Oct 1986, pp. 2224-6													
	AN														
Examiner										Date Considered					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.															

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Examiner <i>Dga</i>		Date Considered <i>1/08/03</i>

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Notice of References Cited	Application/Control No. 10/142,587	Applicant(s)/Patent Under Reexamination VAN DER ZAAG ET AL.	
	Examiner David S Blum	Art Unit 2813	Page 1 of 1

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* * *	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-US006461901B1	10-2002	Noguchi	438/158
B	US-US006414164B1	07-2002	Afzali-Ardakani et al	549/59
C	US-US006504175B1	01-2003	Mei et al	257/66
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
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J	US-			
K	US-			
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M	US-			

FOREIGN PATENT DOCUMENTS

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	N				
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NON-PATENT DOCUMENTS

* * *	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
U	Stanley Wolf SILICON PROCESSING for the VSLI ERA Vol. 1 Lattice Press 1986 pages 452,468-471,480,501-502				
V	John L. Vossen THIN FILM PROCESSES II Academic Press 1991 pages 34-35				
W					
X					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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